

Electronic Patent Application Fee Transmittal

Application Number:	10759641
Filing Date:	16-Jan-2004
Title of Invention:	PURGING GAS FROM A PHOTOLITHOGRAPHY ENCLOSURE BETWEEN A MASK PROTECTIVE DEVICE AND A PATTERNED MASK
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Filer:	Michael Mallie/In Chung
Attorney Docket Number:	42P10058D

Filed as Large Entity

Utility Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1400	1400
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Total in USD (\$)				1700